L	Hits	Search Text	DB	Time stamp
Number				
2	585810	substrate or wafer	EPO; JPO;	2004/02/23
3	1577	(dut or (device adj under adj test))	IBM_TDB EPO; JPO; IBM TDB	15:36 2004/02/23 15:36
1	1	((interfer or interfere or interference	EPO; JPO;	2004/02/23
	_	or interfering or interferometer or interferometrically or interferometric) and ((dut or (device adj under adj test)))) and (substrate or wafer)	IBM_TDB	15:37
4	30	<pre>(interfer or interfere or interference or interfering or interferometer or interferometrically or interferometric) and ((dut or (device adj under adj test)))</pre>	EPO; JPO; IBM_TDB	2004/02/23
-	375	(356/477).ccls.	USPAT; US-PGPUB	2004/02/19 15:54
-	973	(356/73.1).CCLS.	USPAT; US-PGPUB	2004/02/19
_	1074	(385/12).CCLS.	USPAT; US-PGPUB	2004/02/23
-	9	385/12.ccls. and (dut or (device adj under adj test))	USPAT; US-PGPUB	2004/02/23
] -	6214	(dut or (device adj under adj test))	USPAT; US-PGPUB	2004/02/23 15:36
-	555755	interfer or interfere or interference or interfering or interferometer or interferometrically or interferometric	USPAT; US-PGPUB	2004/02/23
_	1311	<pre>(interfer or interfere or interference or interfering or interferometer or interferometrically or interferometric) and ((dut or (device adj under adj test)))</pre>	USPAT; US-PGPUB	2004/02/23 15:36
-	648590		USPAT; US-PGPUB	2004/02/23 15:36
-	605	<pre>((interfer or interfere or interference or interfering or interferometer or interferometrically or interferometric) and ((dut or (device adj under adj test)))) and (substrate or wafer)</pre>	USPAT; US-PGPUB	2004/02/23 15:36
-	25	, , , , , , , , , , , , , , , , , , , ,	USPAT; US-PGPUB	2004/02/23
_	109		USPAT; US-PGPUB	2004/02/23